

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/890,290	CHENG ET AL.	
Examiner	Art Unit	
Krishnan S. Menon	1723	

	SEARCHED			
Class	Subclass	Date	Examiner	
210	321.6 321.61 321.74 - 321.8			
	321.84 to			
	321.89			
	450			
	500.27			
264	41 129			
156	69 187			
	192			
	244.12			
95	54			
96	8,10	6/4/2005	KM	

INT	INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner	
	l			

SEARCH (INCLUDING SEAF		Y)
	DATE	EXMR
Inventor search and search update for RCE	6/4/2005	КМ
156/293 word search	1/28/2006	КМ